



Final Presentation

Predicting Macroscopic Phenomena with Density-Functional Theory

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Outline

Density-Functional Theory (DFT)

- Motivation
- Introduction to DFT (Hartree-Fock \Rightarrow Kohn-Sham)
- DFT implementation in VASP
- Sample applications of DFT (formation energies, transition barriers, band structure, bulk properties)

Anomalous F diffusion modeled via DFT

- Full $F_n V_m$ model
- Continuum model based on DFT results
- Simplified $F_3 V$ model
- Calibration of simplified F model to SIMS data

Summary and conclusion

Motivation



Goal: Study N electron quantum systems

Requires: N particle wave function

$$\Psi(r_1, \dots, r_N)$$

Exact treatment is numerical challenging:
(m # of sampling points in one direction)

$$\text{memory} \propto m^{3N}$$

Example: bulk Si (2 atoms in primitive cell, 14 electrons per Si atom)

$$\text{memory} = 8\text{Byte} \cdot 10^{3 \cdot 2 \cdot 14} \approx 10^{73} \text{TB} \quad \Rightarrow \text{“currently” impossible}$$

Remember: Solving single particle Schrödinger equation is relative easy and fast



Need to find a way out !!!



Hartree-Fock Method

Idea: Find effective **one** particle Hamiltonian for N electron system and treat remaining N-1 electrons as an effective potential.

Approximation: $\Psi(r_1, \dots, r_N) = A \prod_{i=1}^N \phi_i(r_i)$ (Slater determinant)

Minimize: $E = \langle \Psi | H_0 + V_{ext} | \Psi \rangle =$ **Density:** $n(r) = \sum_{i=1}^N |\phi_i(r)|^2$

$$\dots = \underbrace{\sum_i \int d^3r \frac{\hbar^2}{2m} |\bar{\nabla} \phi_i|^2}_T + \underbrace{\frac{1}{2} e^2 \iint d^3r d^3r' \frac{n(r)n(r')}{|r-r'|}}_{E_{direct}} - \underbrace{e^2 \sum_{i < j} \langle \phi_i \phi_j | \frac{1}{|r-r'|} | \phi_j \phi_i \rangle}_{E_{xc}} + \underbrace{\int d^3r V_{ext}(r) n(r)}_{E_{ext}}$$

Variational principle:

$$\frac{\delta (E[\phi_i, \phi_i^*] + \lambda \langle \psi | \psi \rangle)}{\delta \phi_a^*} = 0 \quad \Rightarrow \text{N Hartree-Fock-Equation}$$



Hohenberg-Kohn Theorem

Theorem: “There is a variational functional for the ground state energy $E[n]$ of the many electron problem in which the varied quantity is the electron density.”

Hamiltonian: $H = T + U + V_{ext} = H_0 + V_{ext}$

N particle density: $n(r) \equiv \langle \Psi | \Psi^\dagger(r) \Psi(r) | \Psi \rangle$

Universal functional: $F[n(r)] \equiv \langle \Psi | T + U | \Psi \rangle$



$$E_{V_{ext}}[n(r)] \equiv \int dr V_{ext}(r) n(r) + F[n(r)]$$

P. Hohenberg and W. Kohn, Phys. Rev. **136**, B864 (1964)



Free Electron Gas

Fermi gas (non-interacting electron gas):

$$\text{DOS } d^3n = 2 \cdot \frac{V}{(2\pi)^3} d^3k$$

$$\left. \begin{aligned} N &= \frac{V}{3\pi^2} k_F^3 \\ T &= \frac{V\hbar^2}{10m} k_F^5 \end{aligned} \right\} t = \frac{T}{V} = \frac{3}{10} \frac{\hbar^2 (3\pi^2)^{2/3}}{m} n^{5/3}$$

Interacting electron gas: $E_{HF} = T + E_{direct} + E_{XC} + E_{ext}$

\Rightarrow exchange term $e_{XC} = \frac{E_{XC}}{V} = -\frac{3}{4\pi} e^2 (3\pi^2)^{1/3} n^{4/3}$

Simplest DFT: Thomas-Fermi theory

- Positive background field (jellium model)
- T of Fermi gas
- Drop exchange term

$$\Rightarrow E_{TF} = E[n]$$



Kohn-Sham Theory

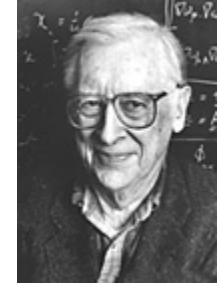
The Nobel Prize in Chemistry 1998

Kohn: “for development of density-functional theory”

Pople: “for development of comput. methods in quant. chemistry”



Walter Kohn



John A. Pople

Kohn-Sham functional:

$$E_{KS}[\phi_1, \dots, \phi_N] = \underbrace{\sum_i \int d^3r \frac{\hbar^2}{2m} |\vec{\nabla} \phi_i|^2}_T + \underbrace{\frac{1}{2} e^2 \iint d^3r d^3r' \frac{n(r)n(r')}{|r-r'|}}_{E_{direct}} + E_{XC}[n] + \underbrace{\int d^3r V_{ext}(r)n(r)}_{E_{ext}}$$

Different exchange functionals:

Local Density Approx. (LDA)

$$E_{XC}[n] \propto n^{4/3}$$

Local Spin Density Approx. (LSD)

$$E_{XC}[n] \propto (n_{\uparrow}^{4/3} + n_{\downarrow}^{4/3})$$

General Gradient Approx. (GGA)

adding term $f(\vec{\nabla} n)$

Other: PW91, B3LYP

W. Kohn and L.J. Sham, Phys. Rev. **140**, A1133 (1965)



Predictions of DFT

Atomization energy:

Method	Li ₂	C ₂ H ₂	20 simple molecules (mean absolute error)
Experiment	1.04 eV	17.6 eV	-
Theoretical errors:			
Hartree-Fock	-0.94 eV	-4.9 eV	3.1 eV
LDA	-0.05 eV	2.4 eV	1.4 eV
GGA	-0.20 eV	0.4 eV	0.35 eV

Si properties:

Property	Experiment	LDA	GGA
Lattice constant	2.35 Å	2.34 Å	2.36 Å
Bulk modulus	99 GPa	96 GPa	92 GPa
Band gap	1.17 eV	0.52 eV	0.7 eV



Summary of DFT Properties

Features:

- Ground-state theory (excitations can be treated with TDFT)
- Zero temperature theory ($T=0^{\circ}$ K)
- High quality predictions for non-correlation effects

Justification:

“Justification of DFT is given through the **quality of its predictions**. However it is an *ab-initio* Method, since all parameters are determined *a priori* by general considerations.”

Limitations:

- Phenomena which rely on correlation effects (superconductivity, Van der Waals, interactions) can not be predicted. Correlation effects are not built into wave functions.
- System size is limited by CPU power available.



Absolute observables are meaningless, **only differences** are sensitive quantities.

Implementation of DFT in VASP



VASP features:

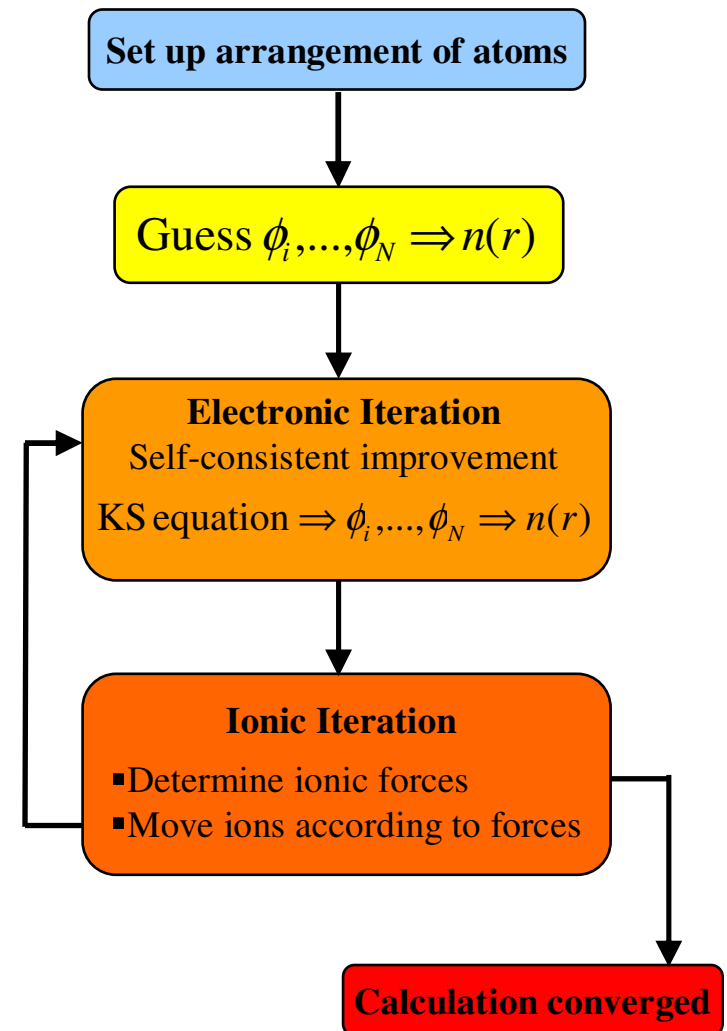
- Plane wave basis
- Ultra-soft Vanderbilt type pseudo-potentials
- Quantum-mechanical molecular dynamics (MD)

VASP output:

- Charge density and wave functions
- Relaxed ion location
- Total energy
- DOS
- ...

Numerical features:

- Highly optimized serial and parallel version





Sample Applications of DFT

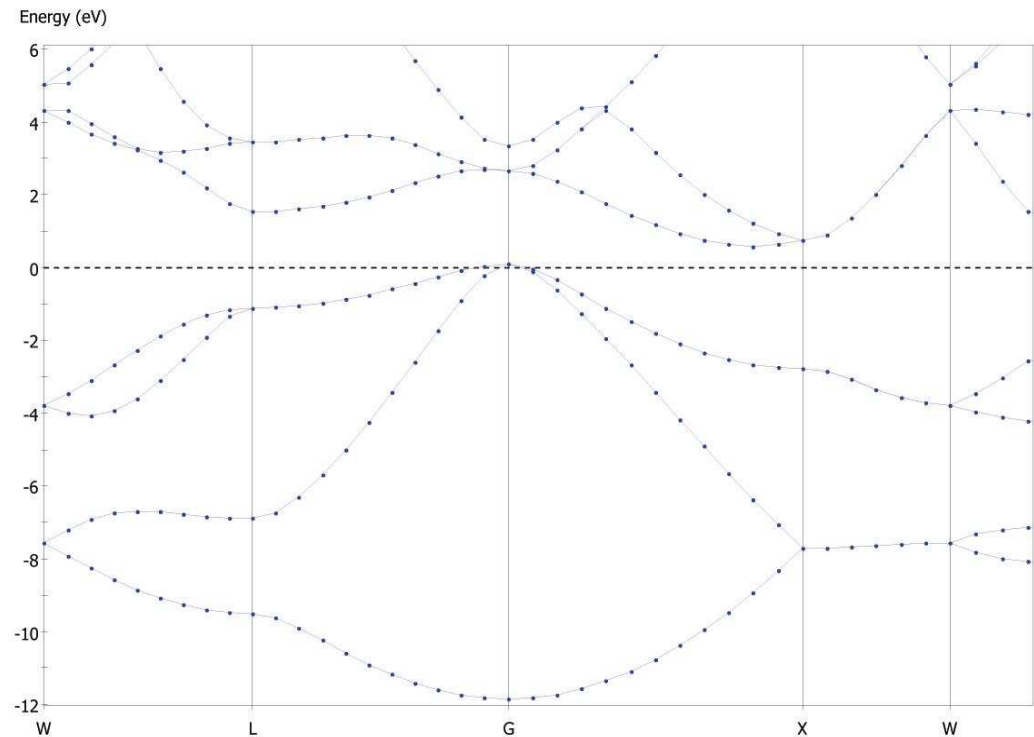
- ◆ Formation energies (F model)
- ◆ Transition barriers (migration energies, diffusivities)
- ◆ Interface properties (segregation coefficients)
- ◆ Bulk properties (lattice constant, bulk modulus, strain effects)
- ◆ Band structure (effect of dopants and defects)



Band structure

- ◆ DFT band gap 0.7eV (experimental 1.12eV)
- ◆ Study band structure changes due to:
 - Dopants
 - Defects
 - Strain
 - Temperature
 - ...

Si band structure



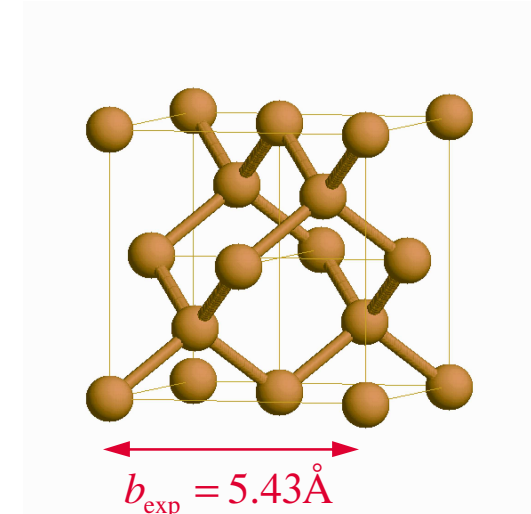
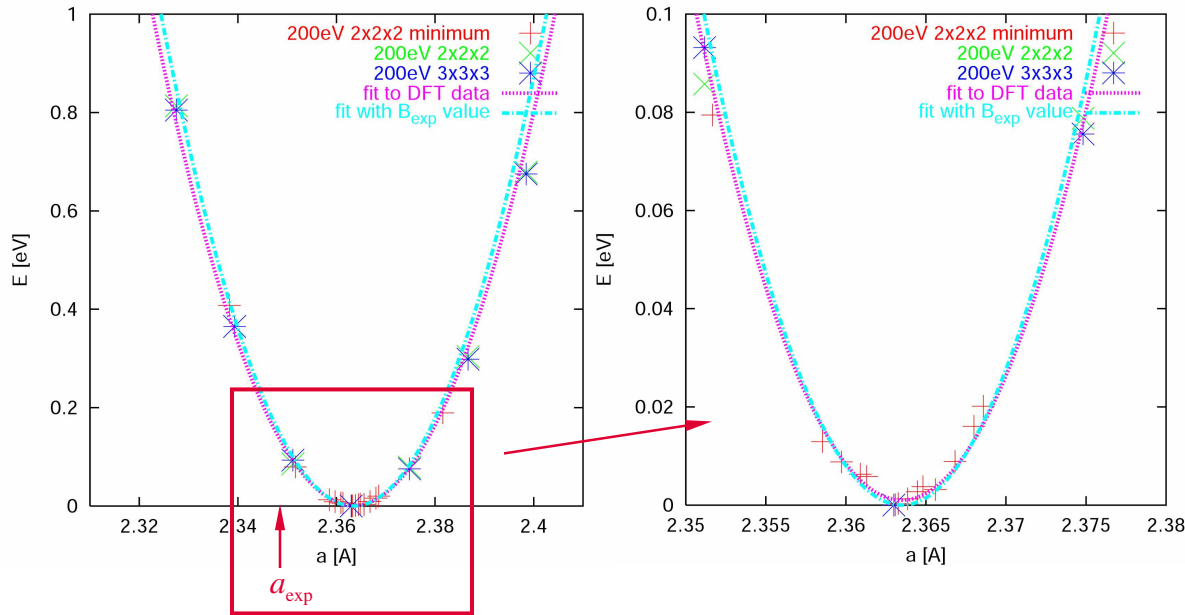
DFT calculation W. Windl

Remember: DFT predicts differences correct



Silicon Bulk Properties

Lattice Constant: Calculate E at varying box size



$$a = \frac{\sqrt{3}}{4} b$$

Bulk modulus:

$$B(V) \equiv V \frac{d^2 E(V)}{dV^2}$$

$$E(a) \Rightarrow E(V)$$

$$B_{exp} = 99 \text{ GPa}$$

$$B_{DFT} = 92 \text{ GPa}$$



Straining Si with Pb

Strain effect of impurities: Ge, Sn, Pb

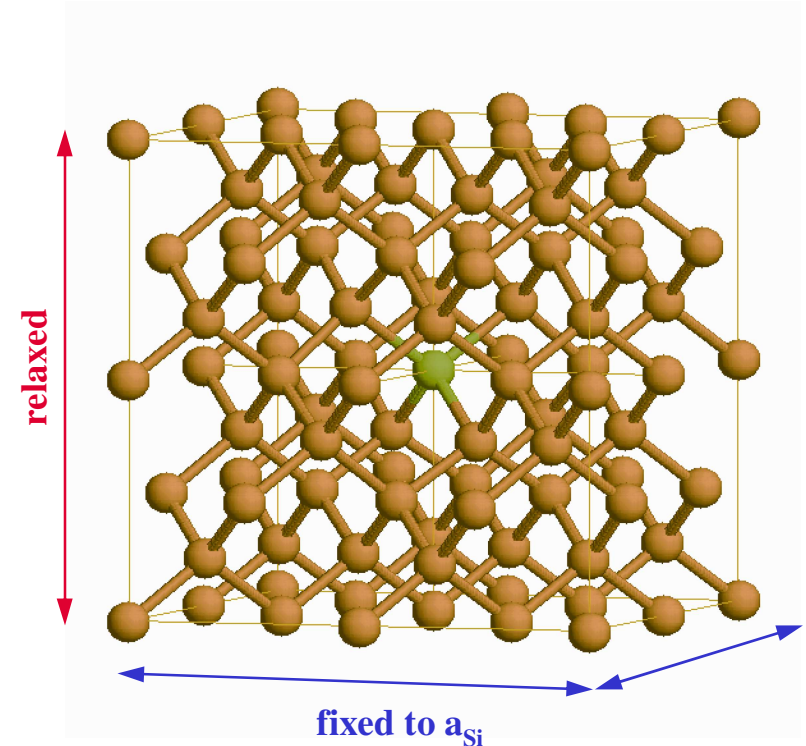
$$a_{eff} = \frac{C_{Si}}{C_S} a_{Si} + \frac{C_{Pb}}{C_S} a_{Pb}$$

Strain: $\delta = \frac{a_{eff} - a_{Si}}{a_{Si}}$

Simple Model: ~ 1% strain

DFT: 0.75% strain

Microscopic strain effects



64 atom supercell
(63 Si + 1 Pb) \Rightarrow 1.56% Pb

$$C_{Pb} \approx 7.8 \cdot 10^{20} \text{ cm}^{-3}$$



Transition Paths and Barriers

Goal: Find transition paths and barriers

Theory: (harmonic) transition state theory (hTST)

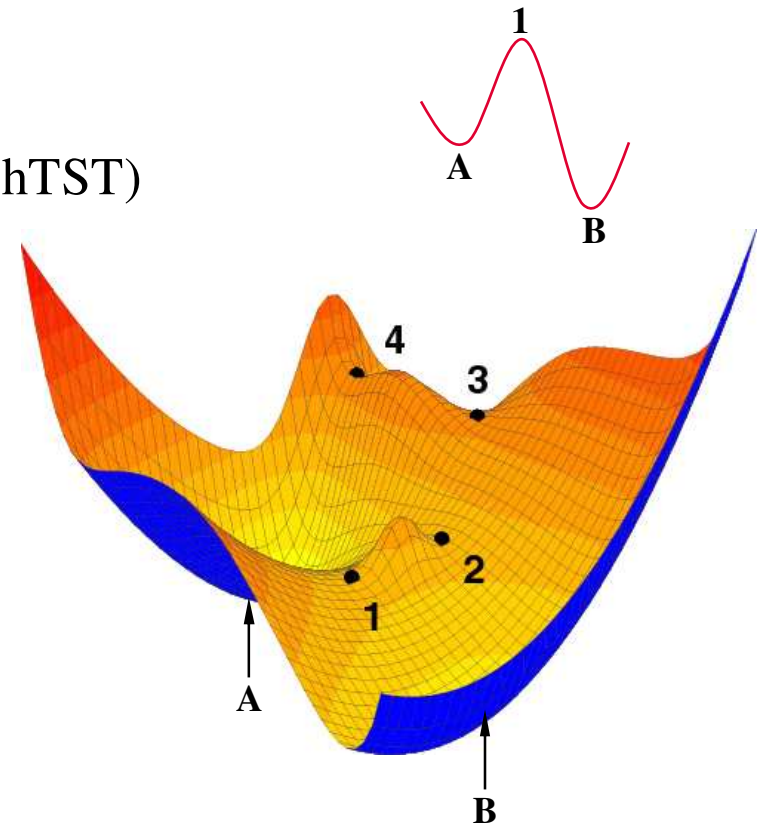
$$D = D_0 \cdot e^{-\frac{E_m}{kT}}$$

Methods:

- Nudged elastic band method (NEB)
- Dimer method

Challenging because:

- High dimensional
- Bumpy energy surface
- End up in unwanted local minimum
- Do not find all reaction paths



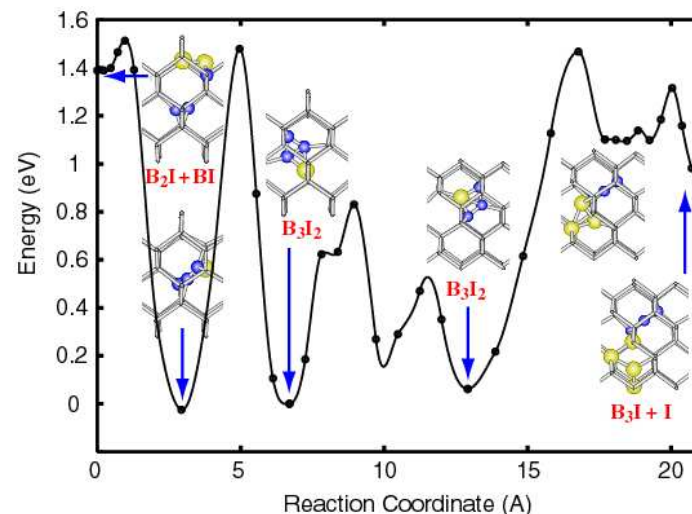
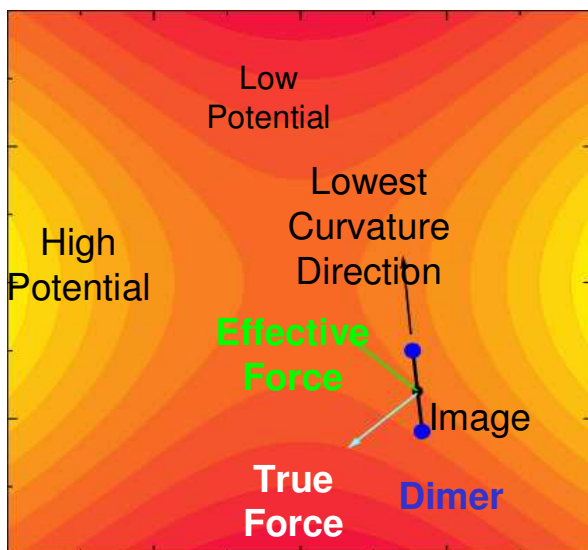
Energy surface of 3N dim. space
(N # of atoms)



NEB and Dimer Method

NEB method:

- Chain of “images” connected by springs
- Springs ensure equidistance between images
- Force minimization converges into possible reaction path
- Initial and final state need to be known



Dimer method:

- Two images form a dimer
- Dimer moves along the lowest curvature mode
- Numerically a little more expensive than NEB
- Do not need to know final state

⇒ Possibility of exploring unknown terrain

G. Henkelman and H. Jónsson, *J. Chem. Phys.*, **111**, 7010 (1999)



Motivation: Fluorine Study

Importance of fluorine: B implantation with BF_2

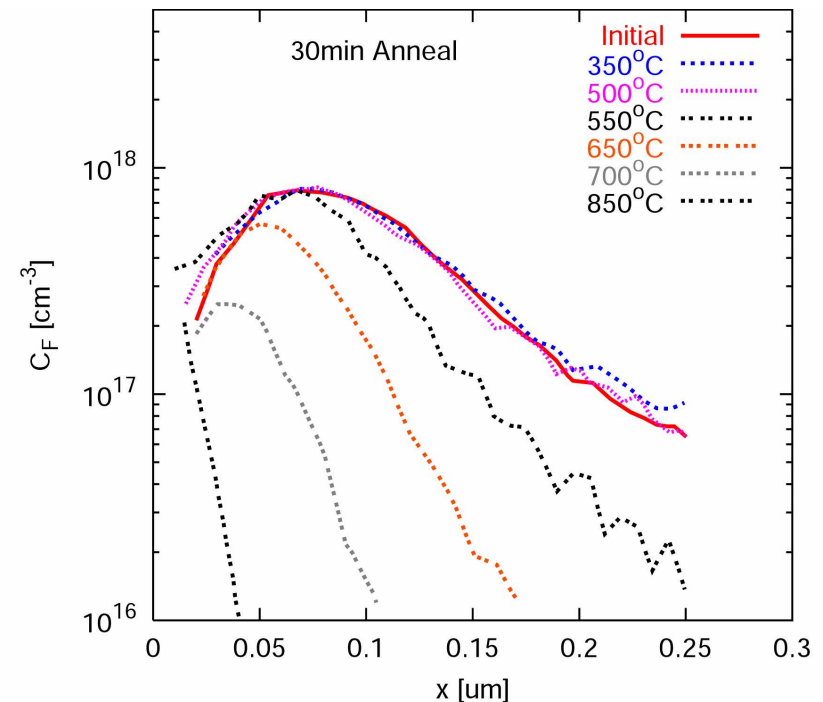
Potential Advantages:

- Enhances B activation (Huang *et al.*)
- TED reduction (Park *et al.*)

Experiment:

Anomalous fluorine diffusion
Behavior (Jeng *et al.*)

30keV F+ implant \Rightarrow anneal
QF = 10^{13} cm^{-2}





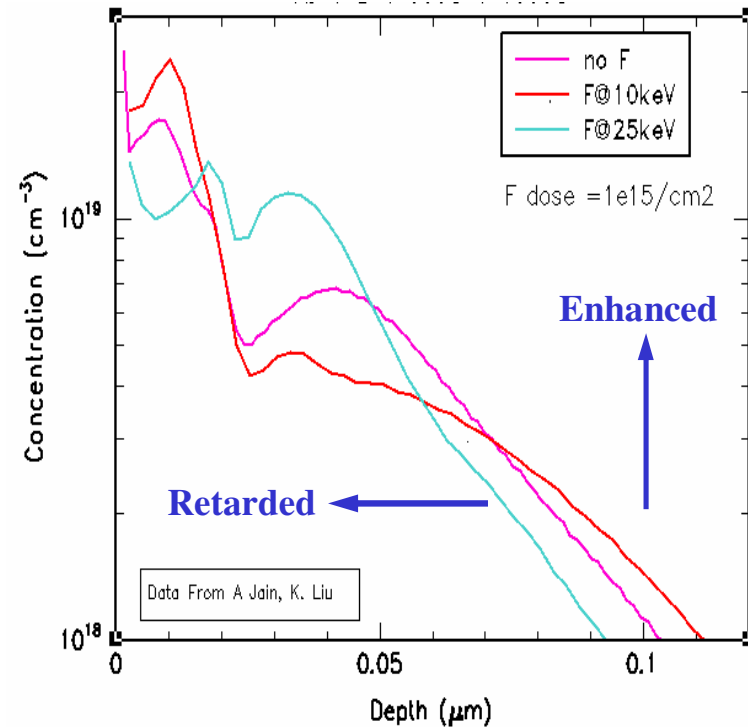
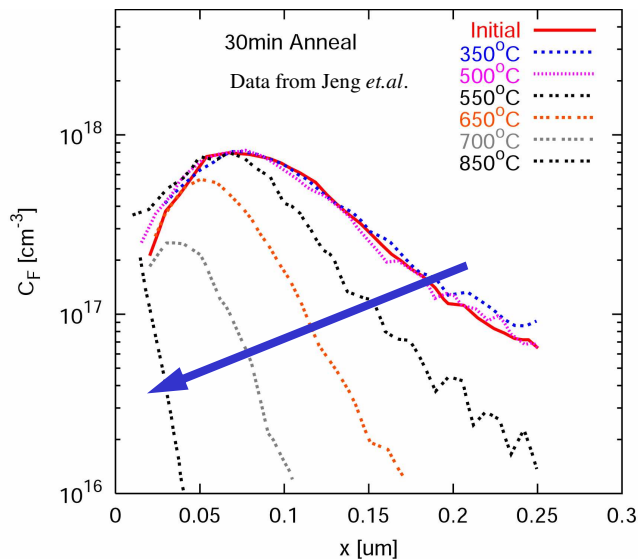
Motivation: Fluorine Study

Why study F ?

- Fluorine retards/enhances B, P
- B activation

F behavior is complex:

- Exhibits anomalous diffusion
- Mechanism debatable:
 - ◆ B + F interaction ?
 - ◆ F interacts with Si point defects (I,V) ?



No comprehensive model available in literature



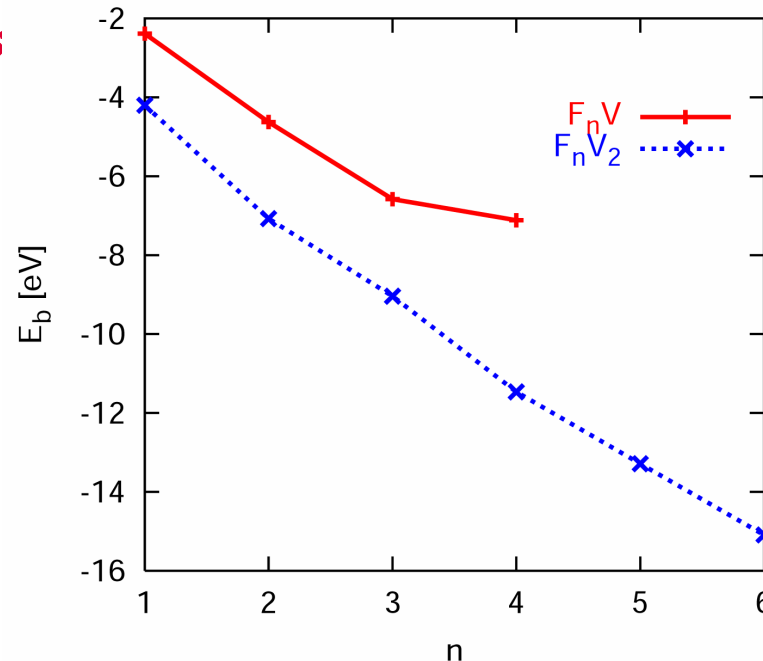
$F_n V_m$ Clusters

Idea: Fluorine decoration of vacancies \Rightarrow immobile clusters

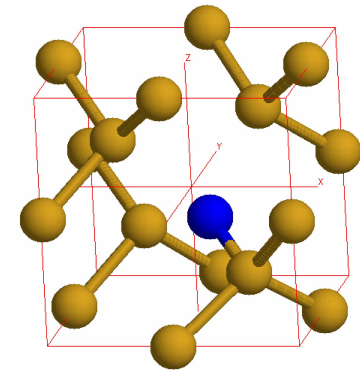
DFT predicts

Reference:

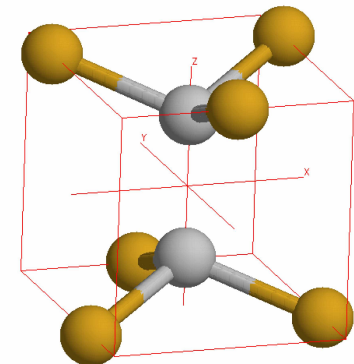
F_i, V



FV:



V₂:

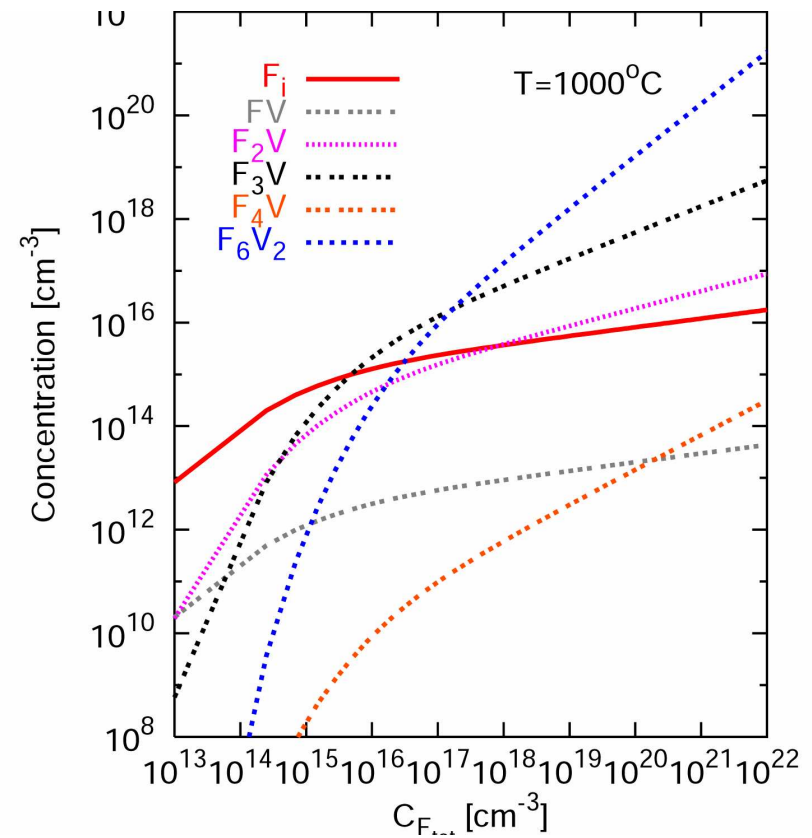
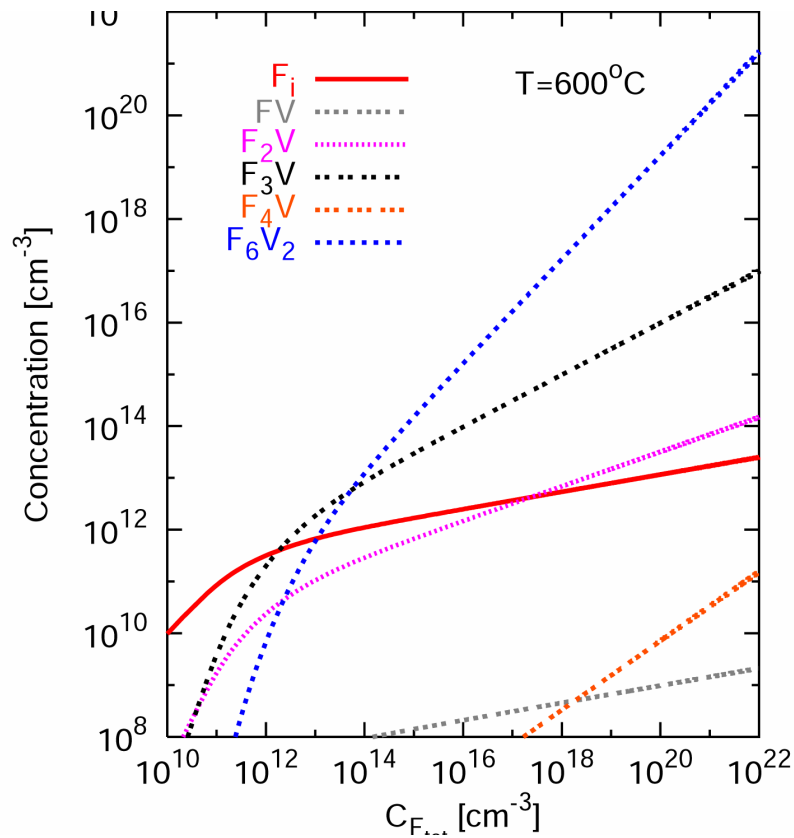


Results:

- $F_n V_m$ clusters have large binding energies
- E_b drop-off $F_3 V \rightarrow F_4 V$ (crowding)



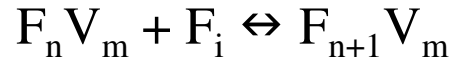
Local Equilibrium



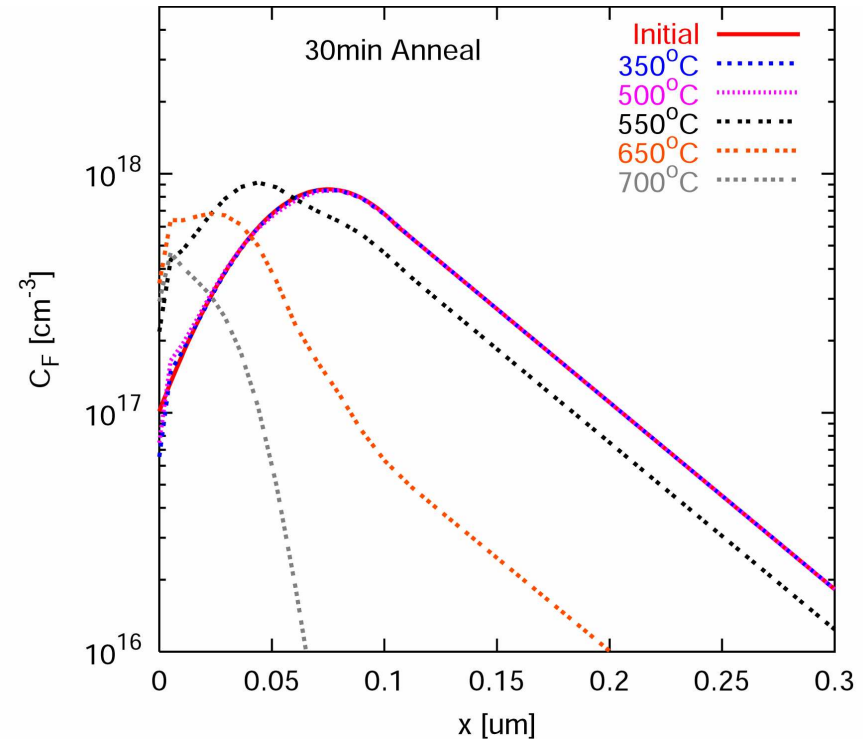
⇒ F_3V and F_6V_2 clusters favored for moderate/high F concentrations

Extended Fluorine Continuum Model

Formation:



Dissociation:



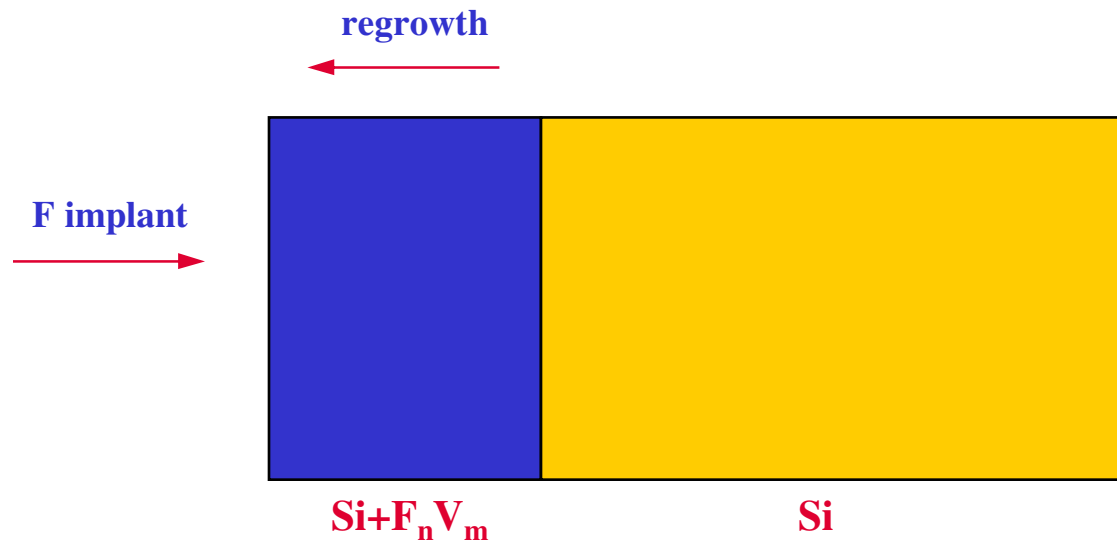
Defect Model & Boundary Conditions:

- Extended defect model including I_n , V_n , and $\{311\}$ defects
- Thin oxide layer on surface (20 \AA) (segregation & diffusion of F_i)

M. Diebel and S.T. Dunham, Mat. Res. Soc. Symp. Proc. 717, Warrendale, PA, 2002



Pre-amorphizing Implant



Possible Interactions:

F causes the incorporation of excess V during regrowth

⇒ TED reduction due to excess V

⇒ B activation due to reduced B/I clusters

Both seen in pre-amorphized samples



Simplified Fluorine Model

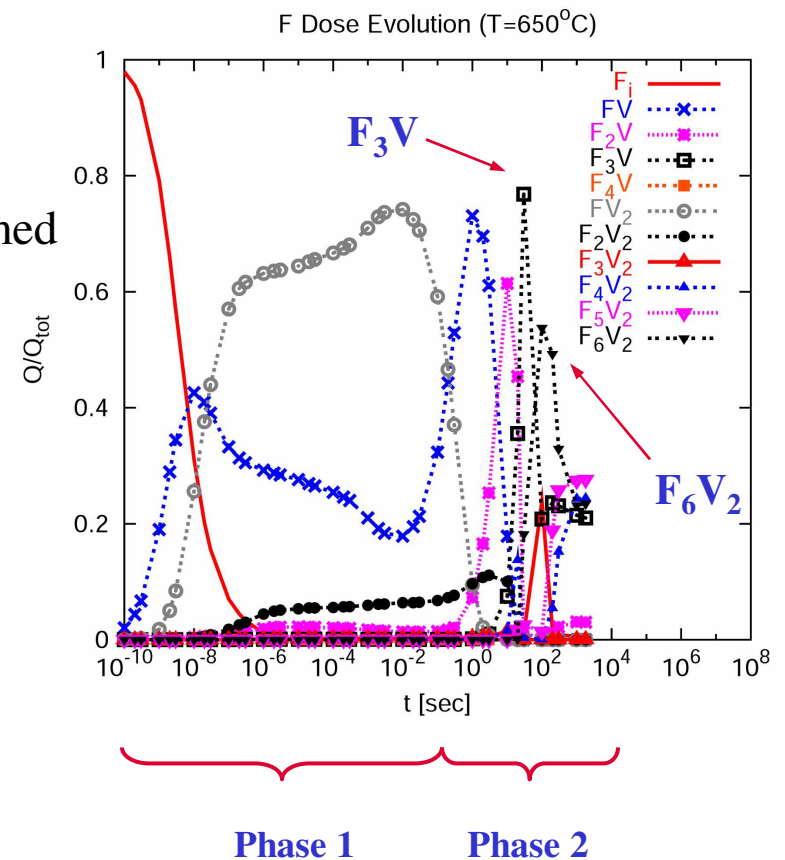
Mechanism:

- F_i diffuses fast and forms FV
- Via cascade larger $F_n V_m$ clusters are formed
- $F_n V_m$ dissolves in presence of I

⇒ assume first two steps are fast

Simplified model:

- Implant large stable $F_n V_m$ cluster ($F_3 V$)
- Implant additional I (shifted R_p)
- Dissolve $F_3 V$ via: $F_3 V + I \leftrightarrow 3 F_i$



Higher T will shift formation to earlier times



Model Implementation

Implant:

- $F_3V \Rightarrow$ effectively $+2/3 I$
- Interstitials (40% shifted R_p) $\Rightarrow +1/3 I$

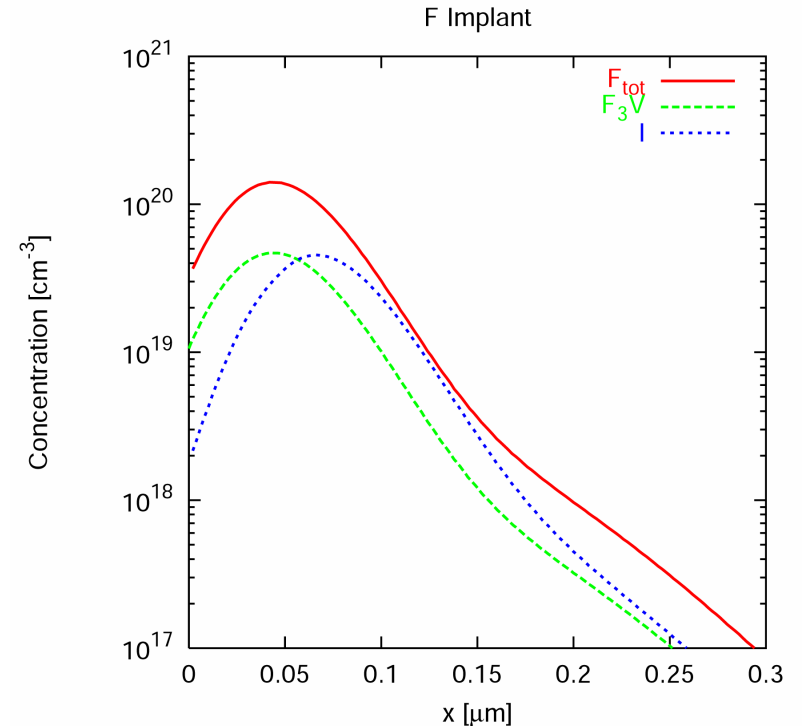
Reactions: $F_3V + I \leftrightarrow 3 F_i$

Parameters:

- F implant moments (analytic expression)
- d.scale, d.plus $\Rightarrow a/c$
- F_3V dissolution rate
- F_i diffusivity

Advantage:

Model can treat sub-amorphizing and amorphizing conditions together.





Fluorine Model

Sub-amorphizing condition:

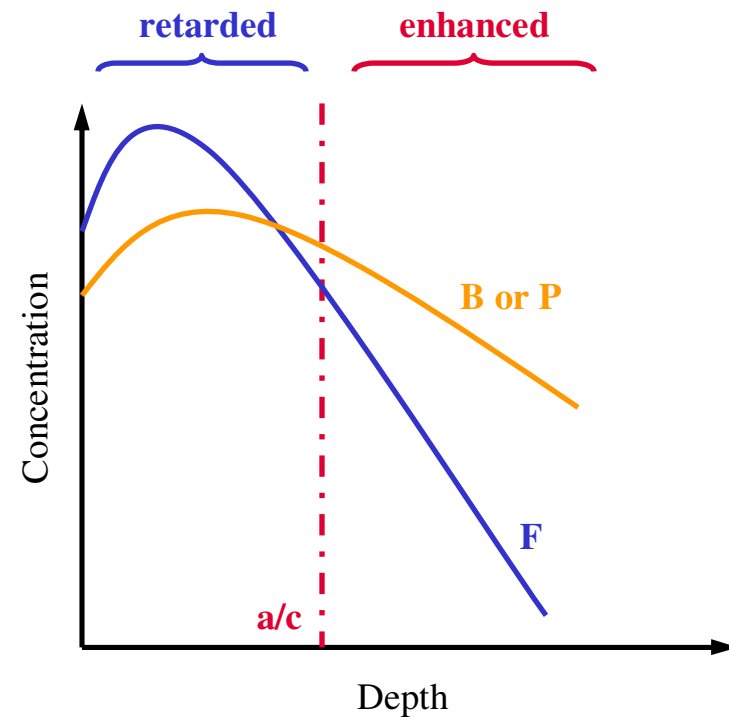
TED effect

Amorphizing condition:

Retardation effect

Effect depends on:

- F concentration
- Dopant concentration
- I concentration





Calibration to SIMS Data

Fluorine only (dose loss)

Fluorine + dopants (fluorine effect on dopants, a/c depth)

	S/D high E + high Q	MDD low E + high Q	Pocket high E + low Q
Boron (PMOS)	✓	✓	✓
Phosphorus (NMOS)	✓		✓



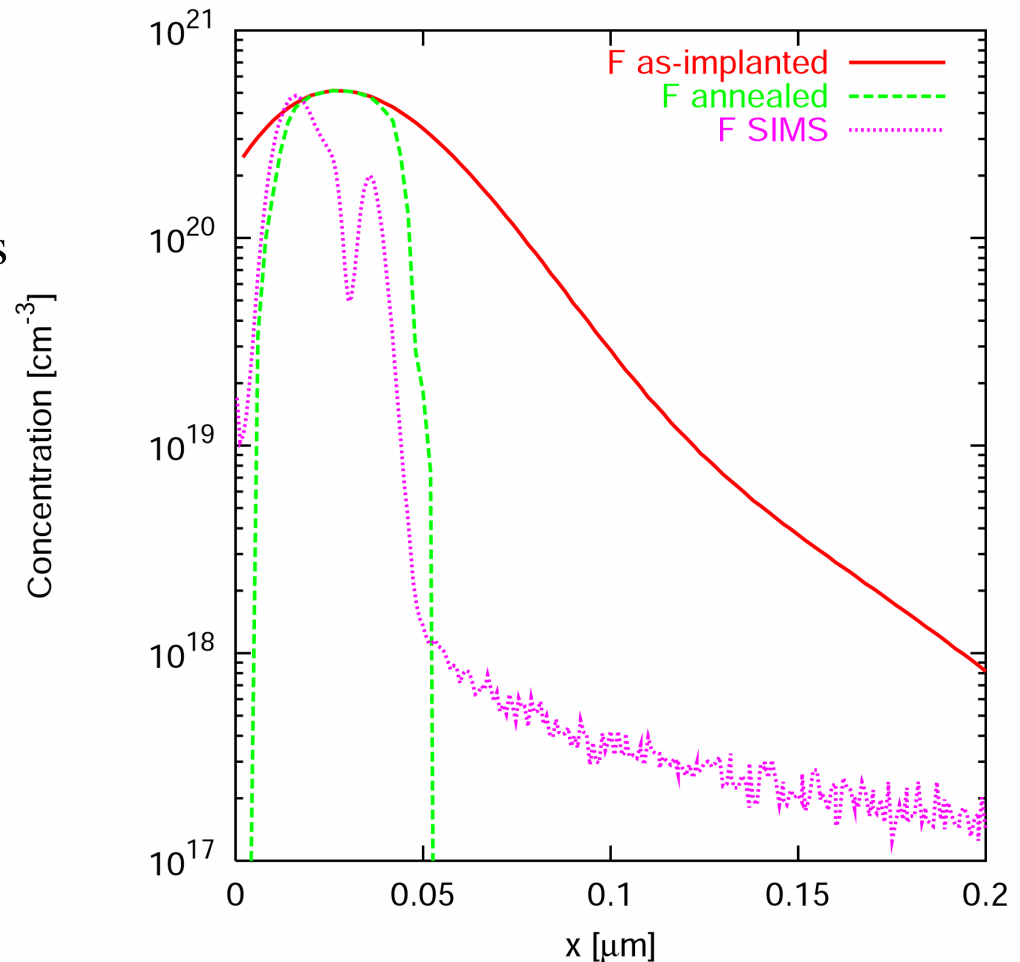
Fluorine Only

Analysis:

- General trend correct
- Underestimates dose loss

Experiment:

- 100A Poly Ox
- **F 20keV 3e15**
- 1050C spike anneal

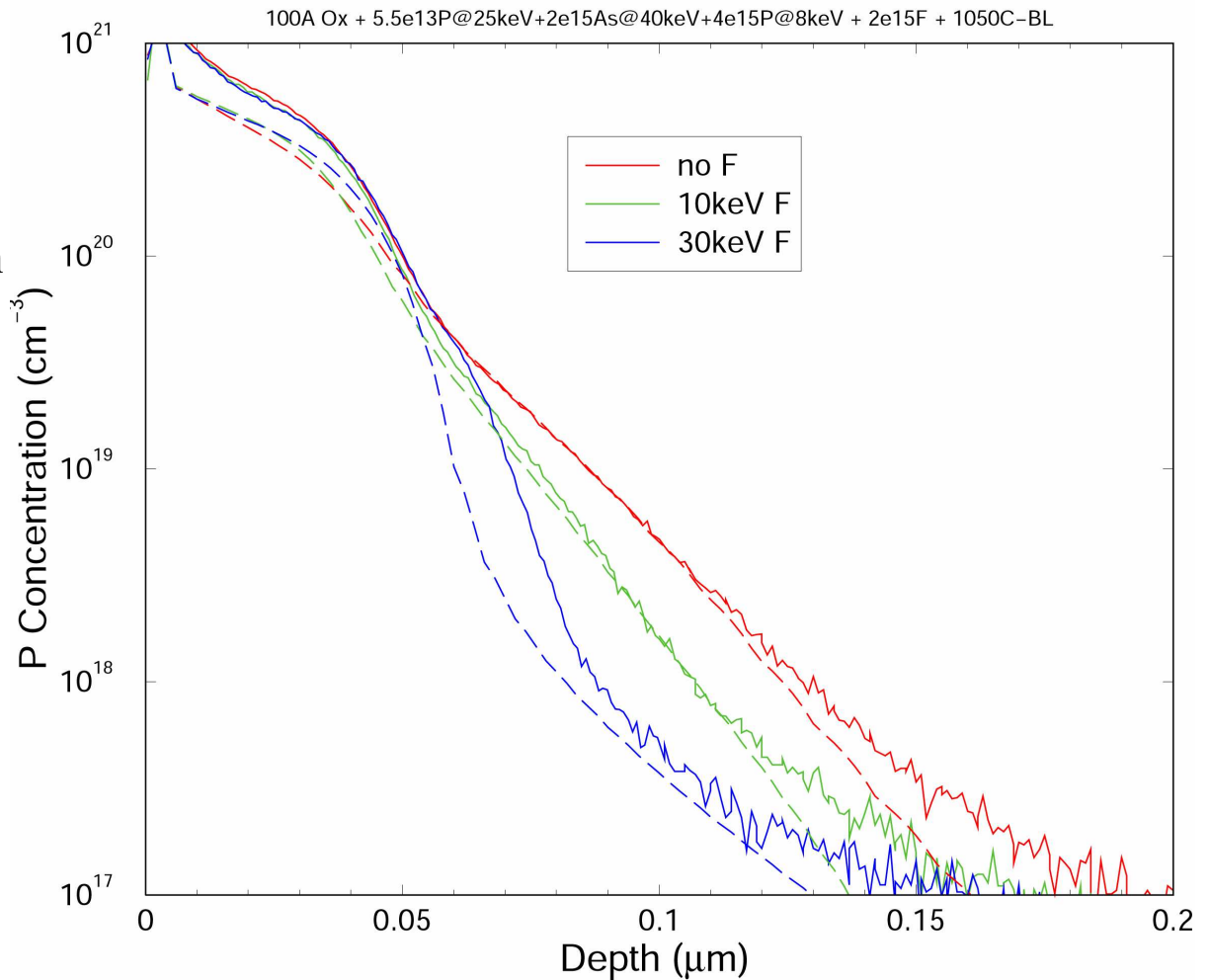




Phosphorus-Fluorine S/D

Analysis:

- Trend correct
- Overestimates retardation





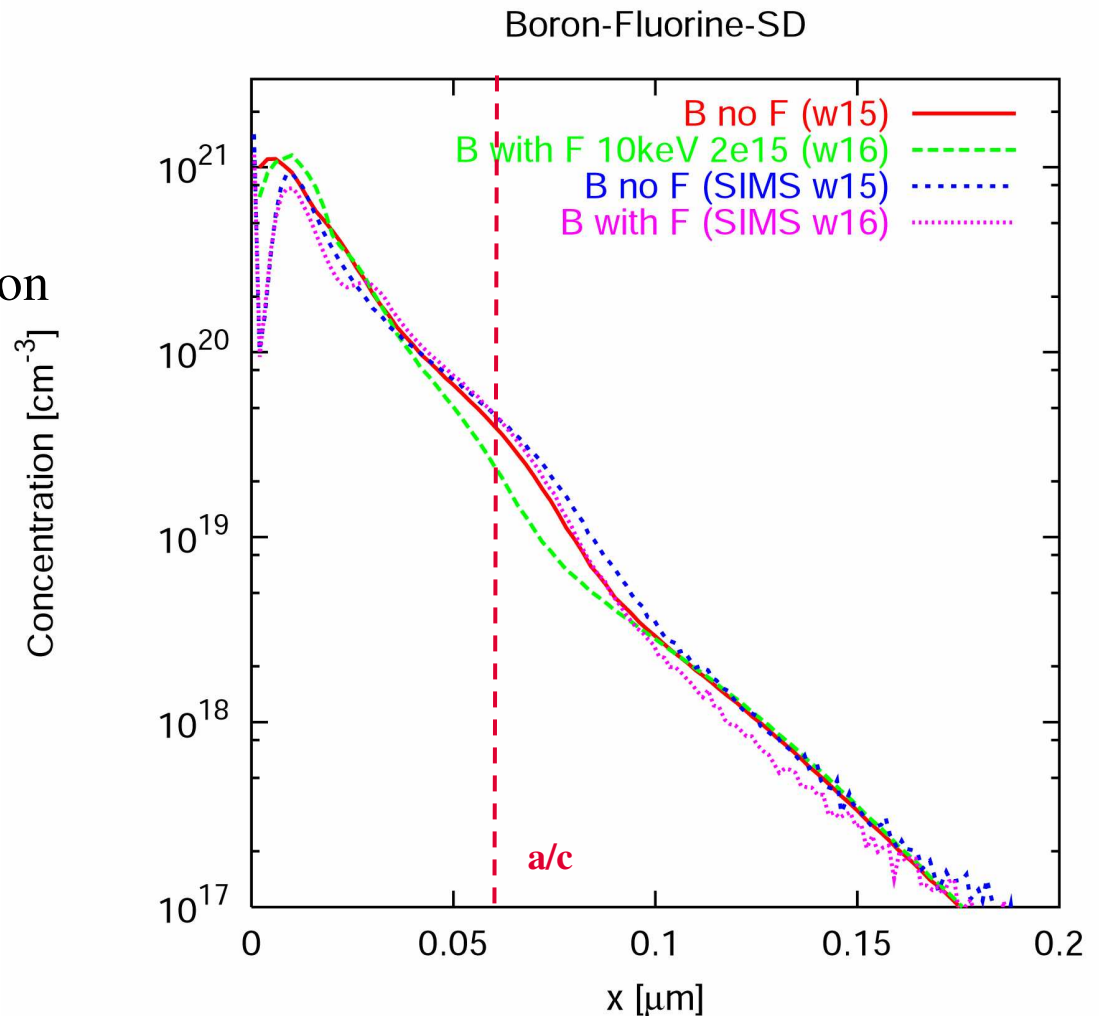
Boron-Fluorine S/D

Analysis:

- Trend correct
- Overestimates retardation

Experiment:

- P 25keV 5.5e13
- As 40keV 2e15
- P 10keV 1.5e15
- **F 10keV 2e15**
- 1050C spike anneal





Boron-Fluorine Pocket

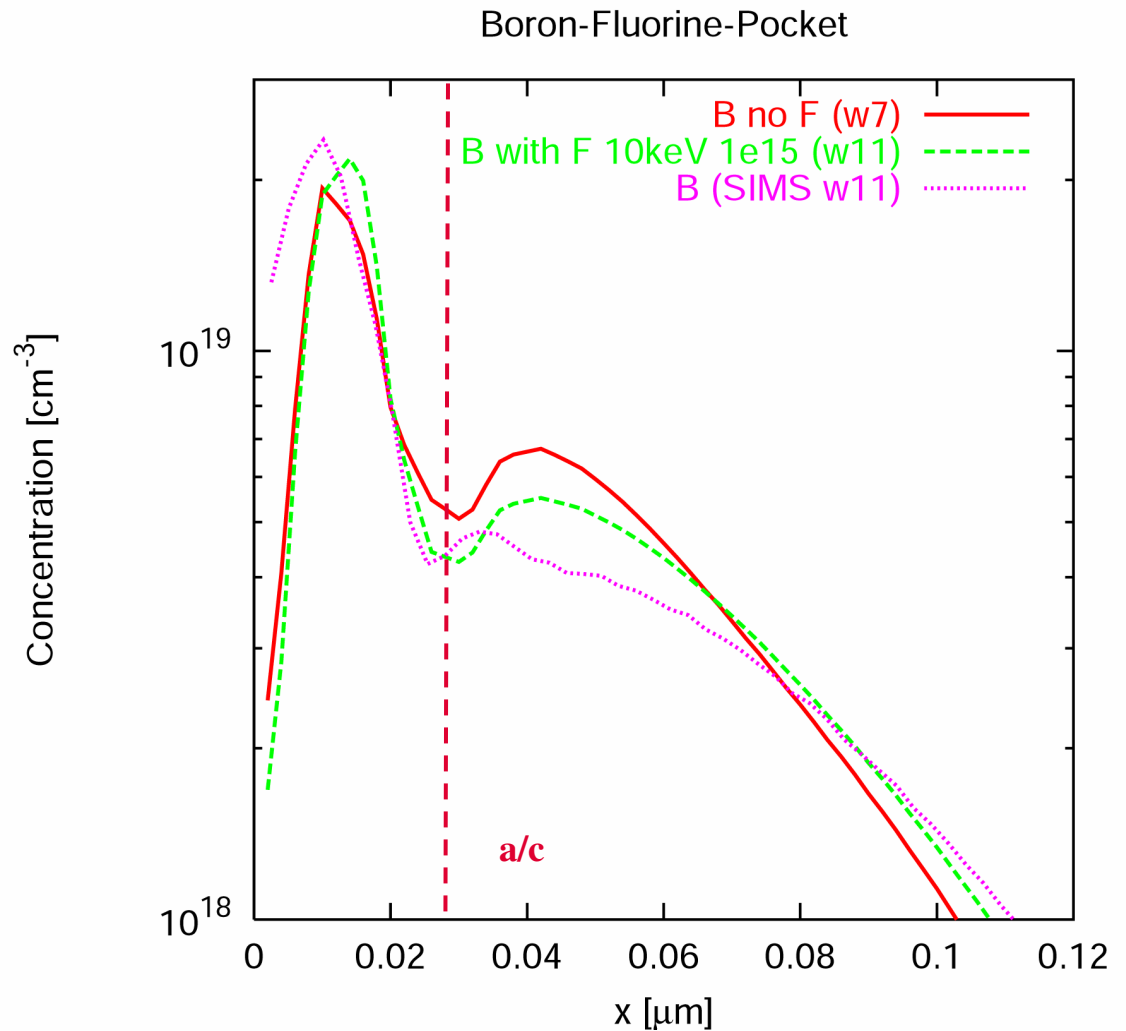
Analysis:

- Tail diffusion **enhanced**

Experiment:

- As 5keV 2e15
- B 10keV 6e13
- **F 10keV 1e15**
- 950C spike anneal
- 1050C spike anneal

Lot: Fluorine-Effects I
Amitabh Jain and Kaiping Liu





Phosphorus-Fluorine Pocket

Analysis:

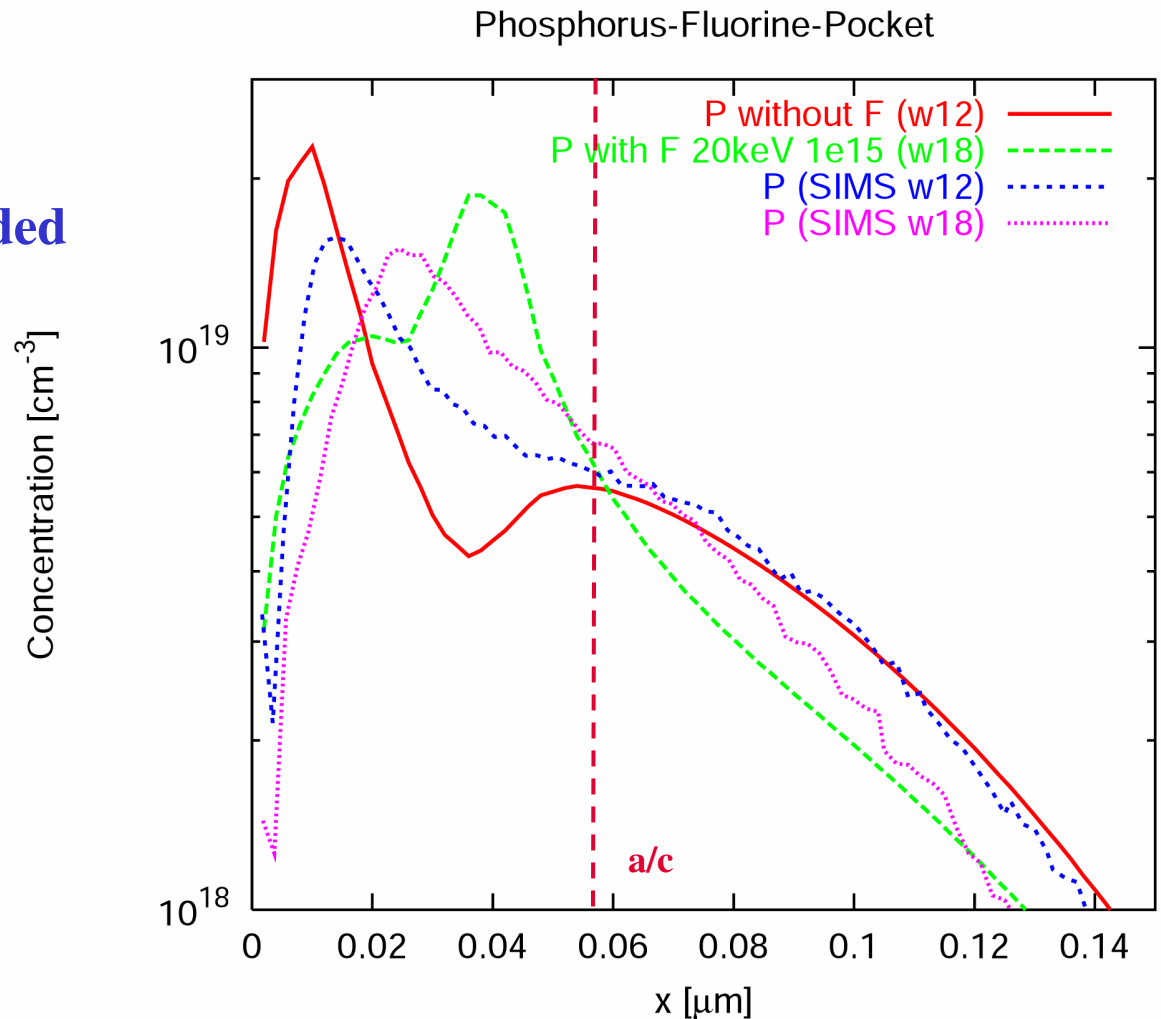
- Tail diffusion **retarded**

Experiment:

- Sb 30keV 3e13
- **F 20keV 1e15**
- BF₂ 6keV 1e15
- 950C spike anneal
- 1050C spike anneal

Lot: Fluorine-Effects II

Amitabh Jain and Kaiping Liu





Summary and Conclusion

Summary: New F_3V model developed for TS4

Predicts:

	S/D high E + high Q	MDD low E + high Q	Pocket high E + low Q
Boron (PMOS)	Ok	Poor	Ok
Phosphorus (NMOS)	Good		Ok

Confirms DFT calculation:

F effect is primarily due to changes in I and V, not B-F or P-F binding.

Problems: F_3V model predicts stronger retardation effects

Possible improvements:

- Initial conditions (formation of $F_n V_m$ important)
- Larger clusters (2 or more clusters)



References

Density-Functional-Theory

- ◆ G.F. Bertsch, Les Houches Lecture July 2000
- ◆ G.F. Bertsch and K. Yabana, Lecture Notes Graduiertenkolleg Rostock, Germany 2001/Summer School Trieste, Italy 2001
- ◆ <http://www.nobel.se>

F Diffusion Model

- ◆ M. Diebel and S.T. Dunham, Mat. Res. Soc. Symp. Proc. 717, Warrendale, PA, 2002.

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